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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Inventor: Daniel I. Some

Title: Full Frame Thermal Pump Probe Technique For Detecting Subsurface Defects

Serial No.: 10/812,817

Filing Date: March 29, 2004

Examiner: Unknown

Group Art Unit: Unknown

Docket No.: APM003 US

Confirmation No.:

Santa Clara, California
February 25, 2005

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR STATUS OF APPLICATION

Sir:

Applicant(s) hereby request(s) a report on the status of the above-identified patent application.

In particular, please advise when this application is expected to be examined.

If a telephone call would expedite this request, please telephone the undersigned attorney at (408) 982-8203.

I hereby certify that this correspondence is being transmitted by facsimile to the U.S. Patent and Trademark Office to the fax number 703-872-9306 on February 25, 2005.



Attorney for Applicant(s)

Respectfully submitted,



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Reg. 36,320

Serial No. 10/812,817